



Attorney Docket No. 0756-2409

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/021,719

Filed: December 19, 2001

For: LASER ANNEALING METHOD AND

SEMICONDUCTOR DEVICE

FABRICATING METHOD

) Group Art Unit: 2818

) Examiner: D. Le

) CERTIFICATE OF MAILING
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2005

) Adam M. Stampen

REVISED SUPPLEMENTAL AMENDMENT

*Please enter this paper
into the file 11/14/05*
Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the
above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 13 of this paper.